IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

priority Application Serial No	10/177,054
Confirmation No.	
priority Filing Date	June 21, 2002
Inventor	
Assignee	Micron Technology, Inc.
Group Art Unit	unknown
Examiner	unknown
Attorney's Docket No	Ml22-2504
Customer No	021567
Title: Methods of Forming Spaced Conductive Region	s, and Methods of Forming
Capacitor Constructions	

PRELIMINARY AMENDMENT

To:

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

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AMENDMENTS